

GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

PROPORTIONS

CLARITY CHARACTERISTICS

KEY TO SYMBOLS

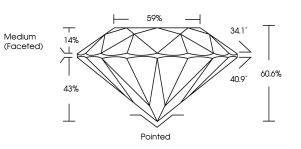
Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

July 9, 2024								
IGI Report Number	LG642451034							
Description	LABORATORY GROWN DIAMOND							
Shape and Cutting Style	ROUND BRILLIANT							
Measurements	8.02 - 8.04 X 4.87 MM							
GRADING RESULTS								
Carat Weight	1.91 CARAT							
Color Grade	E							
Clarity Grade	VS 2							
Cut Grade	IDEAL							
ADDITIONAL GRADING INFORMATION								

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	(G1 LG642451034

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



LG642451034

Report verification at igi.org



Sample Image Used

July 0 2024

	July 9, 2024
LG642451034	IGI Report Number
BORATORY GROWN DIAMOND	Description LABC
ROUND BRILLIANT	Shape and Cutting Style
8.02 - 8.04 X 4.87 MM	Measurements
	GRADING RESULTS
1.91 CARAT	Carat Weight
E	Color Grade
VS 2	Clarity Grade
IDEAL	Cut Grade

LABORATORY GROWN DIAMOND REPORT

59% 34.1° 14% Medium (Faceted) 60.6% 40.9° 43% Pointed

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	低到 LG642451034
Comments: This Laboratory created by Chemical Vapo process. Type IIa	



D E F	GHIJ	Faint	Very Light	Light		
CLARITY						
IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³		
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included		



42451034	MM	1.91 CARAT		VS 2	IDEAL	60.6%	869	Medium (Faceted)	Pointed	BXCELLENT	EXCELLENT	NONE	1691 LG642451034	Comments: The Locatory Grown Damond was ended by Chemical Vapor Deposition (CVD) growth process.	
July 9, 2024 IGI Report No LG642451034 ROUND BRILLANT	8.02 - 8.04 X 4.87 MM	Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)	Comments: This Laboratory Grown created by Chemical (CVD) growth process (ype lid	